



TO AF

PATENT
8040-1052

IN THE U.S. PATENT AND TRADEMARK OFFICE

O.K TO ENTER

In re application of

Taishi KUBOTA et al.

Conf. 8011

Application No. 10/763,244

Group 2823

Filed January 26, 2004

Examiner Trung Q. Dang

T. DANG

8/20/06

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
AND OXIDIZATION METHOD OF SEMICONDUCTOR
SUBSTRATE

RESPONSE AFTER FINAL REJECTION

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 16, 2006

Sir:

This responds to the Official Action mailed May 17,
2006.

Remarks begin on page 2 of this paper.